



Attorney Docket No.: SAM-0465  
Application Serial No.: 10/685,738  
Reply to Office Action of: September 14, 2005

AT  
IPW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Kyung-soo Kim, *et al.* Examiner: Chen, Kin Chan  
Serial No.: 10/685,738 Group Art Unit: 1765  
Filing Date: October 15, 2003  
Title: METHOD FOR MANUFACTURING MULTI-THICKNESS GATE  
DIELECTRIC LAYER OF SEMICONDUCTOR DEVICE

CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8

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AMENDMENT AFTER FINAL

KCC  
11/18/05

Sir:

The following is in response to the Office Action dated September 14, 2005, and is filed within the shortened statutory period of three months. Please amend the application as follows.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.